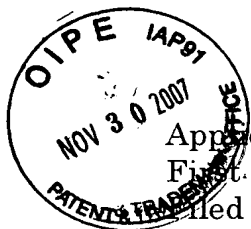


IPW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/518,642  
First Named Inventor : Mitsuhiro YUASA  
Filed : March 15, 2005  
TC/A.U. : 2815  
Examiner : Michael H. Durbin

Confirmation No. : 2849

Docket No. : 101249.55749US  
Customer No. : 23911

Title : Mems Array, Manufacturing Method Thereof, and Mems  
Device Manufacturing Method Based on the Same

**REPLY**

**Mail Stop AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in  
response to the non-final Office Action dated September 17, 2007.

**Amendments to the Claims** are reflected in the listing of claims which  
begins on page 2 of this paper. *No additional claims fees are due.*

**Remarks** begin on page 8 of this paper.